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OFFICIAL

- Appl. No. 09/699,897

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/699,897
Filing Date October 27, 2000
Inventor..... Mathew S. Cooper
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1753
Examiner R. McDonald
Attorney's Docket No. H0001190 (4016)
Title: Physical Vapor Deposition Components and Methods of Formation

STATEMENT OF THE SUBSTANCE OF AN INTERVIEW

To: Commissioner for Patents
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AMENDMENTS